

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
Yasuhiro WATANABE, et al. : Confirmation Number: 4618
Application No.: 10/575,680 :
Filed: April 13, 2006 : Group Art Unit: 2828
For: TWO-BEAM SEMICONDUCTOR LASER APPARATUS :
Examiner: ZHANG, Yuanda

AMENDMENT FILED WITH RCE

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

A Request for Continued Examination and the following amendment and remarks are submitted in response to the Office Action mailed on September 29, 2009, having a three-month shortened statutory period for response set to expire December 29, 2009.

Amendments to the Claims are reflected in the listing of claims beginning on page 2 of this paper. This listing of claims replaces all prior versions, and listings, of claims in the application.

Remarks begin on page 4 of this paper.